

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE
PATENT APPLICATION

In re Application of:

Tsung et al.

Serial No.: 09/921,324

Filed: 08/02/01

For: MASS PRODUCTION OF CROSS-SECTION TEM SAMPLES BY
FOCUSED ION BEAM DEPOSITION AND ANISOTROPIC ETCHING

Docket: TI-30243

Art Unit: 2823

Examiner: G. Fourson III

Assistant Commissioner for
Patents
Washington, D.C. 20231

CERTIFICATE OF MAILING 37 CFR §1.8(a)

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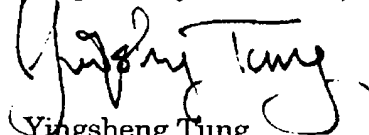
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Sir:

In response to the Examiner's restriction requirement (Paper No. 3) mailed October 31, 2002, Applicants hereby elect to pursue Group II, Claims 13-16 for examination purposes.

Texas Instruments Incorporated
P. O. Box 655474, M/S 3999
Dallas, Texas 75265
(972) 917-5355

Respectfully submitted,


Yingsheng Tung
Attorney for Applicants
Reg. No. 52,305

To: Technology Center 2800
Facsimile Number: (703) 872-9318

Total Pages Sent :2

From: Yingsheng Tung
Texas Instruments Incorporated
Facsimile: 972-917-4418
Phone: 972-917-5355

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Examiner: J. Chen

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CERTIFICATION OF FACSIMILE TRANSMISSION

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NAME OF INVENTOR(S): Tsung et al.	
RECEIPT DATE & SERIAL NO. Serial No.: 09/921,324	
TITLE OF INVENTION: Mass Production of Cross-Section TEM Samples by Focused Ion Beam...	
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Texas Instruments Incorporated
PO Box 655474, M/S 3999
Dallas, TX 75074